

NAK1-AY33ara

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4-24-02

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application for Reissue of:

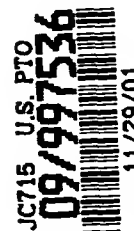
U.S. Patent No. 5,993,543

Issued: November 30, 1999

Applicant: Masaki Aoki et al.

Serial No.: 08/890,577

For: METHOD OF PRODUCING PLASMA DISPLAY
PANEL WITH PROTECTIVE LAYER OF AN
ALKALINE EARTH OXIDE



CLAIM OF FOREIGN PRIORITY

Box Reissue
Assistant Commissioner for Patents
Washington, DC 20231

Dear Sir:

We, the inventors, declare that the earliest application for patent or inventors' certificate on this invention filed in any country foreign to the United States of America by us or our legal representatives or assigns is as follows:

Japanese Patent Application No. 7-326766 filed on December 15, 1995

Japanese Patent Application No. 8-016326 filed on February 1, 1996

Japanese Patent Application No. 8-162639 filed on June 24, 1996

Japanese Patent Application No. 8-223428 filed on August 26, 1996

We hereby declare that all statements made herein of our own knowledge are true, and that all statements made on information and belief are believed to be true; and further, that these statements are made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment, or both, under Section 1001 of Title 18 of the United States Code and such willful false statements may jeopardize the validity of the application or any patent issued thereon.

Executed on _____, 2001, at _____,
Japan.

Masaki Aoki

Executed on _____, 2001, at _____,
Japan.

Hideo Torii

Executed on _____, 2001, at _____,
Japan.

Eiji Fujii

Executed on _____, 2001, at _____,
Japan.

Mitsuhiro Ohtani

Executed on _____, 2001, at _____,

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Takashi Inami

Executed on _____, 2001, at _____,

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Hiroyuki Kawamura

Executed on _____, 2001, at _____,

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Hiroyoshi Tanaka

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Ryuichi Murai

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Yasuhisa Ishikura

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Yutaka Nishimura

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Katsuyoshi Yamashita